



PATENT
Attorney Docket 2344-738

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of)	
)	
Ofer Sneh)	Group Art Unit: 1762
)	
Serial No.: 10/052,890)	Examiner: Not Yet Assigned
)	
Filed: October 19, 2001)	
)	
Title: PROCESS FOR TUNGSTEN SILICIDE)	
<u>ATOMIC LAYER DEPOSITION</u>)	

PRELIMINARY AMENDMENT

Mail Stop Non-Fee
Commissioner of Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

Introductory Comments:

This Supplemental Preliminary Amendment is submitted prior to examination on the merits.
Entry of this amendment is respectfully requested.

Please amend the above-identified application as follows: